## **EAST Search History**

| Ref<br># | Hits  | Search Query          | DBs · | Default<br>Operator | Plurals | Time Stamp       |
|----------|-------|-----------------------|-------|---------------------|---------|------------------|
| L1       | 44010 | silicon carbide       | USPAT | SAME                | OFF     | 2006/09/13 15:45 |
| L2       | 5103  | I1 and single crystal | USPAT | SAME                | OFF     | 2006/09/13 15:45 |
| L3       | 2156  | I2 and wafer          | USPAT | SAME                | OFF     | 2006/09/13 15:45 |
| L4       | 520   | l3 and epitaxial film | USPAT | SAME                | OFF     | 2006/09/13 16:05 |
| L5       | 198   | 13 and epitaxial film | USPAT | NEAR                | OFF     | 2006/09/13 16:05 |

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|----------|-------|-----------------------|-------|---------------------|---------|------------------|
| L1       | 44010 | silicon carbide       | USPAT | SAME                | OFF     | 2006/09/13 15:45 |
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| L5       | 198   | l3 and epitaxial film | USPAT | NEAR                | OFF     | 2006/09/13 16:05 |

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